

INFORMATION DISCLOSURE CITATION FORM FOR PATENT APPLICATION (FORM PTO-1449) (Substitute)			Docket No.: 871-011413-US(PAR)	Serial No.:		
			Applicant(s): David CHOWN			
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U.S. PATENTS						
Initials	Patent Number	Issue Date	Name	Class	Sub-class	Filing date
U.S. PATENT PUBLICATIONS						
Initials	Publication No.	Pub. Date	Name	Class	Sub-class	Filing Date
FOREIGN PATENT DOCUMENTS						
Initials	Document Number	Date	Country	Name		Translation? Yes/No/n/a
OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)						
LP	Patent Abstracts of Japan Publication No. JP 05 029987.					
LP	"Electrically Switchable Mirrors And Optical Components Made From Liquid-Crystal Gels", Hikmet et al., Nature, Vol. 392, No. 6675.					
LP	"Micromachining For Optical And Optoelectronic Systems", Proceedings of the IEEE, Vol. 85, No. 11, 1997.					
LP	"Silica-Based Planar Lightwave Circuits", Proceedings of the IEEE, Journal of Selected Topics In Quantum Electronics", Vol. 4, No. 6, 1998.					
Examiner's Signature: /Leslie Pascal/				Date Considered: 11/07/2006		
Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).						